AMENDMENTS

Please amend the application as follows:

In the Claims

1. (Currently Amended) A method for manufacturing a magnetic inductor core, the method comprising:

depositing layers of ferromagnetic material and at least a first layer of sacrificial conductive material such that a first stack of ferromagnetic layers spaced apart a first predetermined distance is formed and a second stack of ferromagnetic layers spaced apart a second predetermined distance is formed, the first predetermined distance being established by the sacrificial conductive material located between and separating the layers of ferromagnetic material of the first stack, the second predetermined distance being established by the sacrificial conductive material located between and separating the layers of ferromagnetic material of the second stack, the first stack being spaced from the second stack;

depositing a support structure <u>such that the support structure is attached to each of the layers of ferromagnetic material of the first stack and to each of the layers of ferromagnetic material of the second stack;</u> and

maintains separation between the layers of ferromagnetic material of the first stack, thereby leaving the first stack and the second stack of ferromagnetic layers being mechanically supported by the support structure such that the support structure maintains separation between the layers of ferromagnetic material of the first stack and between the layers of ferromagnetic material of the second stack.

- 2. (Previously Presented) The method of claim 1, wherein the depositing steps are performed by electrodeposition.
- 3. (Previously Presented) The method of claim 2, wherein the steps of electrodepositing the layers of the ferromagnetic material and the at least first layer of the sacrificial conductive material are performed in an alternating and repetitive manner.
- 4. (Currently Amended) The method of claim 1, further comprising:

 creating a core mold atop a substrate, wherein the core mold is configured to shape

 shaped such that at least the deposited ferromagnetic and sacrificial conductive materials are

 formed in a preferable manner; and

removing the core mold once the support structure is electrodeposited.

- 5. (Original) The method of claim 1, wherein the support structure is U-shaped.
- 6. (Original) The method of claim 1, wherein the ferromagnetic material is permalloy.
- 7. (Original) The method of claim 1, wherein the sacrificial conductive material is copper.

- 8. (Previously Presented) The method of claim 1, wherein each of the layers of ferromagnetic material has a thickness on an order of or less than a skin depth of the material at a given operating frequency.
- 9. (Original) The method of claim 1, wherein the step of removing is performed by selective etching of the sacrificial conductive material.
- 10. (Withdrawn) A method for manufacturing an integrated inductor, the method comprising:

micro-molding and electroplating a conductive material atop a substrate to form a bottom portion of a conductor coil;

depositing and patterning a layer of photosensitive epoxy atop the bottom portion of the conductor coil;

sequentially electrodepositing at least a first layer of a ferromagnetic material and at least a first layer of a sacrificial conductive material atop the photosensitive epoxy;

electrodepositing a support structure formed of a ferromagnetic material;

selectively etching the sacrificial conductive material, thereby leaving the at least first layer of ferromagnetic material mechanically supported by the support structure which forms a magnetic core for the integrated inductor;

depositing a layer of epoxy resist over the magnetic core;

patterning the epoxy resist to form vertical electrical vias for the vertical portions of the conductor coil;

depositing a layer of photoresist over the epoxy resist;

patterning the photoresist to form horizontal spaces for a top portion of the conductor coil; and

electrodepositing a conductive material filling the vertical electrical vias and the horizontal spaces, thus forming the conductor coil integrally wrapped around the magnetic core.

- 11. (Withdrawn) The method of claim 10, wherein patterning the layer of photosensitive epoxy comprises patterning the photosensitive epoxy to form electrical vias providing electrical access to the bottom portion of the conductor coil.
- 12. (Withdrawn) The method of claim 11, further comprising:

 spin-casting and patterning a thin photoresist layer to clog the electrical vias thus
 protecting the bottom portion of the conductor coil prior to selectively etching.
- 13. (Withdrawn) The method of claim 11, wherein the vertical electrical vias are patterned to match up with the electrical vias that provide electrical access to the bottom portion of the conductor coil.
 - 14. (Withdrawn) A magnetic inductor core comprising:
 - a first stack of ferromagnetic layers spaced apart a first predetermined distance;
 - a second stack of ferromagnetic layers spaced apart a second predetermined distance; and
 - a ferromagnetic support structure mechanically supporting the first and second stack.

- 15. (Withdrawn) The magnetic inductor core of claim 14, wherein the support structure is U-shaped, and wherein the support structure is formed in the center of the magnetic core such that the first stack is supported from a first side of the U-shaped support structure and the second stack is supported from a second side of the U-shaped support structure.
- 16. (Withdrawn) The magnetic inductor core of claim 14, wherein the magnetic core is substantially square-shaped.
- 17. (Withdrawn) The magnetic inductor core of claim 14, wherein the height of each ferromagnetic layer is on the order of the skin depth of a utilized ferromagnetic material at a given operating frequency.
- 18. (Withdrawn) The magnetic inductor core of claim 14, wherein the ferromagnetic layers are formed of permalloy.
- 19. (Withdrawn) The magnetic inductor core of claim 14, wherein the first predetermined distance is substantially the same as the second predetermined distance.

- 20. (Withdrawn) An integrated inductor comprising:
- a magnetic inductor core comprising:
- a first stack of ferromagnetic layers spaced apart a first predetermined distance;

an integrated conductor coil microfabricated around the magnetic inductor core.

- a second stack of ferromagnetic layers spaced apart a second predetermined distance; and
- a ferromagnetic support structure mechanically supporting the first and second stack; and
- 21. (Withdrawn) The integrated inductor of claim 20, wherein the support structure is U-shaped, and wherein the support structure is formed in the center of the magnetic core such that the first stack is supported from a first side of the U-shaped support structure and the second stack is supported from a second side of the U-shaped support structure.
- 22. (Withdrawn) The integrated inductor of claim 21, wherein the height of each ferromagnetic layer of the magnetic core is less than the skin depth of a utilized ferromagnetic material at a given operating frequency.
- 23. (Withdrawn) The integrated inductor of claim 21, wherein the ferromagnetic layers are formed of permalloy.
- 24. (Withdrawn) The integrated inductor of claim 20, wherein the first predetermined distance is substantially the same as the second predetermined distance.

25. (Previously Presented) The method of claim 1, wherein the support structure is formed of a ferromagnetic material.